

Search Notes

Application/Control No.

10/691,691

Examiner

Amelia Rutledge

Applicant(s)/Patent under
Reexamination

MATSUISHI, TAKAYA

Art Unit

2176

SEARCHED

Class	Subclass	Date	Examiner
715	526	2/3/2006	AR
715	526	7/11/2006	AR
715	526	5/1/2006	AR
715	526	9/29/2007	

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST(US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB) --See Search History Printout.	9/29/07	AR
ACM Digital Library search - see search printout	2/2/2006	AR